PATENT APPLICATION

GROUP PROSED IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of

Docket No: Q65550

Hidekazu YAMAZAKI, et al.

Appln. No.: 09/911,394

Group Art Unit: 1732

Confirmation-No.: -5074 -

Examiner: Not-Yet Assigned -

Filed: July 25, 2001

FILM FORMATION METHOD CAPABLE OF PREVENTING FLUCTUATION OF For:

RIBBON

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

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WASHINGTON OFFICE

Date: May 6, 2003

Respectfully submitted.

Registration No. 23,063